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APR 14 2004

**OFFICIAL PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: 005651/ETCH/CHMBR/JB1

Michael BARNES, et al.

Appln. No.: 09/834,343

Group Art Unit: 1763

Confirmation No.: 2414

Examiner: Anna M. Crowell

Filed: April 12, 2001

For: PLASMA REACTOR ELECTRODE

AMENDMENT UNDER 37 C.F.R. § 1.111**MAIL STOP NON-FEE AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated January 28, 2004, please amend the above-identified application as follows on the accompanying pages.

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